

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Steele et al.
 Title: WAFER INSPECTION SYSTEM
 Appl. No.: 10/771,628
 Filing Date: 02/03/2004
 Examiner: Meagan S. Walling
 Art Unit: 2863

CERTIFICATE OF MAILING	
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below.	
Krisse Simoni	
(Printed Name)	<i>Krisse Simoni</i>
(Signature)	<i>Krisse Simoni</i>
May 10, 2006	
(Date of Deposit)	

AMENDMENT AND REPLY UNDER 37 CFR 1.111

Mail Stop Amendment
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated January 11, 2006, concerning the above-referenced patent application.

Applicant has enclosed with this amendment a Petition for Extension of Time to make this response timely.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 9 of this document.

Please amend the application as follows:

05/16/2006 SFELEKE1 00000004 10771628

01 FC:2201

100.00 OP

60.00 OP

05/16/2006 SFELEKE1 00000004 10771628

02 FC:2251